

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**PRIORITY** Application Serial No. ....10/121,298  
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Inventor..... J. A. Drewes  
Assignee.....Micron Technology, Inc.  
**PRIORITY** Group Art Unit.....2824  
**PRIORITY** Examiner ..... B. Smith  
Attorney's Docket No. ....MI22-2342  
Title: Semiconductor Constructions And Methods Of Forming Semiconductor  
Constructions

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
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**AMENDMENTS**

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